



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Ricky S. Amos, et al.

Examiner: Asok K. Sarkar

Serial No: 10/786,901

Art Unit: 2891

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Docket: YOR920030334US1 (16899)

For: CMOS SILICIDE METAL GATE
INTEGRATION

Dated: January 9, 2006

Confirmation No. 6726

Mail Stop Amendment
Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE UNDER 37 C.F.R. § 1.111

Sir:

In response to the Office Action dated September 9, 2005, applicants submit the following amendments and remarks for entry of record in the above-identified patent application.

FIRST CLASS MAIL CERTIFICATION

I hereby certify that I am mailing the attached documents to the Commissioner for Patents on the date specified, in an envelope addressed to Mail Stop Amendment, Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450, and First Class Mailed under the provisions of 37 CFR 1.8.

Dated: January 9, 2006



Leslie S. Szivos, Ph.D.